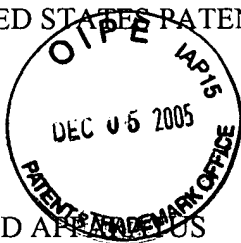


copy ✓

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
Keiji Ishibashi  
Serial No. 09/633,002  
Filed: August 4, 2000  
Title: HOT ELEMENT CVD APPARATUS  
AND A METHOD FOR REMOVING A  
DEPOSITED FILM



)  
) Examiner: Wesley D. Markham  
) Customer No. 00832  
) Patent No.: 6,942,892 B1  
) Issued: September 13, 2005  
)

REQUEST FOR CORRECTION  
UNDER 37 C.F.R. SECTION 1.323

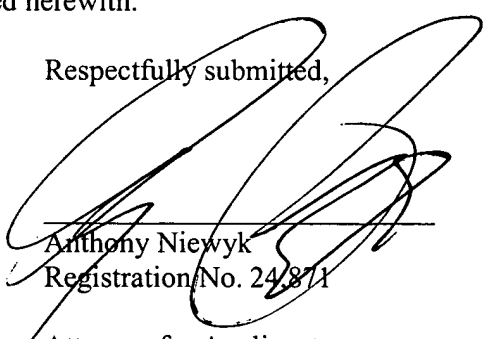
**Certificate**  
**DEC 08 2005**  
**of Correction**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A Certificate of Correction under Rule 1.323 in the above-identified patent is respectfully requested in accordance with the enclosed copies of form PTO-1050. The requisite fee of \$100.00 is included herewith.

Respectfully submitted,

  
\_\_\_\_\_  
Anthony Niewyk  
Registration No. 24,871

Attorney for Applicant

AN/mld

BAKER & DANIELS LLP  
111 East Wayne Street, Suite 800  
Fort Wayne, IN 46802  
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Facsimile: 260-460-1700

Date: November 30, 2005

Enc. PTO-1050 (2)  
Return postcard

12/06/2005 SSITHIB1 00000019 6942892

01 FC:1811

100.00 0P

**DEC 09 2005**

# UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO : 6,942,892 *B1*  
DATED : SEPTEMBER 13, 2005  
INVENTOR(S) : Keiji Ishibashi

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Page, at (73) assignee information, please add the following assignee:

Japan Science and Technology Corporation, Saitama Japan

MAILING ADDRESS OF SENDER: Anthony Niewyk, Reg. No. 24,871  
BAKER & DANIELS LLP  
111 East Wayne Street, Suite 800  
Fort Wayne, IN 46802

PATENT NO. 6,942,892

No. of additional copies



DEC 09 2005

# UNITED STATES PATENT AND TRADEMARK OFFICE

## CERTIFICATE OF CORRECTION

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